## **CLAIMS**

1. A method of manufacturing a multi-layer circuit board in which a core circuit board having a circuit pattern thereon and a prepreg sheet having a through-hole filled with conductive paste are laminated, the method comprising:

forming a laminated structure so that a laminated member formed of the core circuit board and the prepreg sheet is sandwiched between a pair of lamination plates, and applying heat and pressure to the laminated structure,

wherein, the lamination plate is selected so as to have a thermal expansion coefficient equivalent to a thermal expansion coefficient of the core circuit board.

- 2. The method of manufacturing a multi-layer circuit board of Claim 1, wherein the prepreg sheet contains a base and a resin layer impregnated with the base, and a thickness of the resin layer formed on both surfaces of the base is at least 20 µm in total thickness.
- 3. The method of manufacturing a multi-layer circuit board of Claim 1, wherein the core circuit board has four or more layers.
- 4. The method of manufacturing a multi-layer circuit board of Claim 1, wherein the core circuit board is not less than one time as thick as the prepreg sheet.
- 5. The method of manufacturing a multi-layer circuit board of Claim 1, wherein the laminated member further contains metal foil on both surfaces thereof.

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- 6. The method of manufacturing a multi-layer circuit board of Claim 1, wherein the laminated member is formed in a manner that the core circuit board and the prepreg sheet are alternately laminated so as to have two or more layers.
- 7. The method of manufacturing a multi-layer circuit board of Claim 1, wherein buffer material is disposed at outside the laminated structure; the laminated structure is placed on a carrying plate; the laminated structure undergoes heat and pressure through the buffer material and the carrying plate; and a thermal expansion coefficient of the carrying plate equals to a thermal expansion coefficient of the lamination plate.
- 8. The method of manufacturing a multi-layer circuit board of Claim 1, wherein buffer material is disposed at outside the laminated structure; the laminated structure is placed on a carrying plate; the laminated structure undergoes heat and pressure through the buffer material and the carrying plate; and the buffer material is formed of a material capable of accommodating difference in thermal expansion between the lamination plate and the carrying plate.

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- 9. The method of manufacturing a multi-layer circuit board of Claim 1, wherein the prepreg sheet contains a base impregnated with resin and a layer of the resin formed on both surfaces of the base.
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- 10. The method of manufacturing a multi-layer circuit board of Claim 1, wherein the prepreg sheet is a B-staged prepreg in which woven fabric base is impregnated with thermosetting resin.

11. The method of manufacturing a multi-layer circuit board of Claim 1 further including:

measuring thermal expansion coefficient of the core circuit board; and selecting the lamination plate whose thermal expansion coefficient is equivalent to the measured thermal expansion coefficient of the core circuit board.

12. A method of manufacturing a multi-layer circuit board comprising:

measuring thermal expansion coefficient of the core circuit board having a predetermined circuit pattern; and

selecting a lamination plate whose thermal expansion coefficient is equivalent to the measured thermal expansion coefficient of the core circuit board.

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- 13. The method of manufacturing a multi-layer circuit board of Claim 12, wherein the thermal expansion coefficient-measuring is for measuring thermal expansion coefficient of the core circuit board at least two positions of the circuit pattern on the core circuit board in a range from room temperature to a heat pressing temperature by using a thermo-mechanical measurement apparatus.
- 14. The method of manufacturing a multi-layer circuit board of Claim 12, wherein the thermal expansion coefficient-measuring is for measuring thermal expansion coefficient of the core circuit board at two or more positions, and the method further comprising:

calculating an average value of thermal expansion coefficient of the core circuit board according to measurement carried out at two or more

positions; and

selecting the lamination plate whose thermal expansion coefficient is equivalent to the calculated average value of thermal expansion coefficient.